

## AMENDMENTS TO THE CLAIMS

1. (Withdrawn) A method of manufacturing an electron-emitting element for emitting electrons from diamond, comprising:  
  
the first step of forming a diamond columnar member on a diamond substrate; and  
  
the second step of forming an electron-emitting portion having a base portion and a sharp-pointed portion which is located closer to a distal end side than the base portion and emits the electrons by performing etching processing with respect to the columnar member.
2. (Withdrawn) A method according to claim 1, wherein the etching in the second step is plasma etching.
3. (Withdrawn) A method according to claim 1, wherein in the second step, a portion of the diamond substrate other than a portion where the columnar member is formed is masked, and reactive ion etching is performed with respect to the columnar member.
4. (Withdrawn) A method according to claim 1, wherein  
  
in the first step, the diamond substrate is etched after a circular mask portion is formed on a surface of the diamond substrate, and  
  
in the second step, the electron-emitting portion is formed by performing etching with respect to the columnar member with a ratio of an etching rate in a lateral direction to an etching rate in a longitudinal direction being higher than that in the etching in the first step.
5. (Currently Amended) An electronic device comprising:

an electron-emitting element manufactured by the method defined in claim 1; and  
an electron extraction electrode placed to oppose the sharp-pointed portion, with a voltage being applied between said electron extraction electrode and said electron-emitting element,  
wherein the electron emitting portion has a polygonal cross section and a further intermediate portion located between the base portion and the sharp-pointed portion.

6. (Original) A device according to claim 5, further comprising:  
a metal gate electrode formed around the base portion of said electron-emitting element; and  
a power supply for applying a voltage to said gate electrode.
7. (Withdrawn) A method of manufacturing an electron-emitting element for emitting electrons from diamond, comprising:  
the first step of forming a diamond columnar member on a diamond substrate; and  
the second step of forming an electron-emitting portion having a base portion, a sharp-pointed portion for emitting the electrons, and a columnar intermediate portion located between the base portion and the sharp-pointed portion by performing diamond synthesis processing with respect to the columnar member.
8. (Currently Amended) An electronic device comprising:  
an electron-emitting element manufactured by the method defined in claim 7; and  
an electron extraction electrode placed to oppose the sharp-pointed portion, with a voltage being applied between said electron extraction electrode and said electron-emitting element,

wherein the electron emitting portion has a polygonal cross section and a further intermediate portion located between the base portion and the sharp-pointed portion.

9. (New) A device according to claim 5, wherein the base portion is in the shape of a pyramid, and the intermediate portion is in the shape of a prism.

10: (New) A device according to claim 8, wherein the base portion is in the shape of a pyramid, and the intermediate portion is in the shape of a prism.